University of Iowa Microfabrication Facility (UIMF)
User Fees 2015-2016 (Academic and External rates)

Wet-Processing and Metrology Lab (IATL170)

$ 30/hr on any tools

Thin Film, Etching and Nanoimprint Lab (IATL 174)

Cleanroom usage only: $ 25/hr.
Cleanroom access fee: $ 25/day (unlimited access for the day).
Rate on any tools: $ 50/hr.

Electron Beam (E-Beam) Nanolithography (IATL 172)

Cleanroom usage only: $ 25/hr.
Cleanroom access fee: $ 25/day (unlimited access for the day).
E-Beam Lithography: $ 70/hr.

Important Notes:
* Users who book tools in IATL 174 and 172 will be automatically charged the cleanroom access fee.
* Any tool booked is charged in 15 min. increment and is the minimum charge.
* Users will NOT be charged for simply swiping their card to access IATL 172 and 174 to collect items.
* External academic users and UI affiliated companies will follow the same above charge model.
* External industrial users will be charged at twice the academic rates.

Aju Jugessur Ph.D.
Director, University of Iowa Microfabrication Facility